



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

August 8, 2026

IGI Report Number

LG826651997

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

CUSHION MODIFIED BRILLIANT

Measurements

9.96 X 7.57 X 5.03 MM

GRADING RESULTS

Carat Weight

3.04 CARATS

Color Grade

F

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

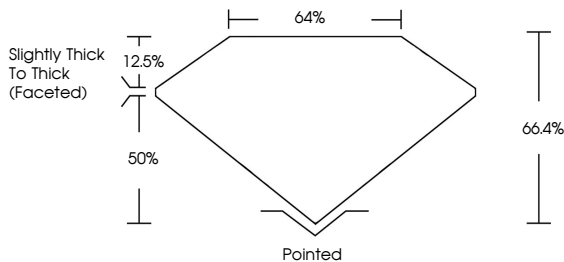
 LG826651997

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

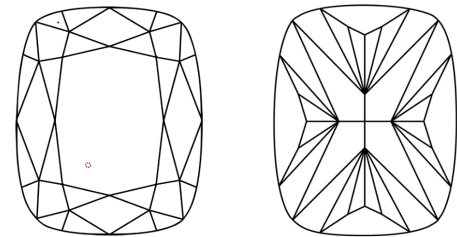
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Report verification at [igi.org](https://www.igi.org)

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

Sample Image Used



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IGI



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CUSHION MODIFIED BRILLIANT

9.96 X 7.57 X 5.03 MM

3.04 CARATS

F

Color Grade

VVS 2

Depth

50%

Table

66.4%

Girdle

Slightly Thick To Thick (Faceted)

Culet

Pointed

Polish

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Symmetry

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Fluorescence

NONE

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